

NOV 12 2002



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Gary M. Moore

Assignee: Moore Epitaxial Inc.

Title: METHOD OF CONTROLLING GAS FLOW TO A SEMICONDUCTOR
PROCESSING REACTOR

Serial No.: 09/765,919 Filed: January 18, 2001

Examiner: Chen, Bret P. Group Art 1762
Unit:

Docket No.: MTEC101001

Monterey, CA
November 6, 2002

Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Dear Sir:

In response to the Office Action dated August 6, 2002,
enclosed herewith are:

1. A separate paper entitled "Clean Copy of Description Replacement Paragraphs" with a clean version of each replacement paragraph in the specification along with a clear instruction for entry (3 pages); and
2. A separate paper entitled "Version with Markings to Show Changes Made" with markings to show amendments to the specification (4 pages).

The above papers are incorporated herein by reference in their entireties as a part of this paper.

RECEIVED
NOV 12 2002
U.S. PATENT & TRADEMARK OFFICE
1700 FLAHL ROOM